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<b>** CONTINUING DATA *****</b> <i>NONE</i> <i>KU 3/18/06</i>					
<b>** FOREIGN APPLICATIONS *****</b> <i>KU 3/18/06</i> REPUBLIC OF KOREA 2003-45786 07/07/2003					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 06/07/2004</b>					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowable	Examiner's Signature <i>KU</i> Initials <i>LL</i>	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 5	TOTAL CLAIMS 30	INDEPENDENT CLAIMS 3
<b>ADDRESS</b> Laura M. Kelley Myers Bigel Sibley & Sajovec, P.A. P.O. Box 37428 Raleigh , NC 27627					
<b>TITLE</b> Metal deposition apparatus used in fabrication of semiconductor devices and methods of forming metal layers using the same					
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